

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/757,276
Filing Date January 14, 2004
Inventor Kevin L. Beaman et al.
Assignee Micron Technology, Inc.
Group Art Unit 2813
Examiner Stephen W. Smoot
Attorney's Docket No. MI22-2475
Customer No. 021567
Title: A Method of Forming a Structure Over a Semiconductor Substrate

**RESPONSE TO JULY 3, 2007 NOTICE OF ALLOWANCE
TO ACCOMPANY REQUEST FOR CONTINUED EXAMINATION (RCE)**

To: Mail Stop: Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

From: D. Brent Kenady
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Spokane, WA 99201-3817

Responsive to the Notice of Allowance dated July 3, 2007, Applicant amends and
remarks as follows:

AMENDMENTS

Underlines indicate insertions and ~~strikeouts~~ indicate deletions.

In the Claims

There are no claim amendments.